

DO NOT ENTER: /WPF/

Docket No.: 20241/0203479-US0
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Nobuo KIMURA *et al.*

Application No.: 10/553,109

Filed: March 13, 2006

For: METHOD FOR PRODUCING ORGANIC THIN
FILM

Confirmation No.: 2398

Art Unit: 1792

Examiner: William P. Fletcher III

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated April 2, 2009, finally rejecting claims 1-4, 12, 19, 25-29, 55, and 57-62, please amend the above-identified U.S. patent application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 11 of this paper.

It is believed that no additional fees are required for this Response. However, should additional fees be necessary in connection with the filing of this Response, or if a petition for extension of time is required for timely acceptance of the same, the Commissioner is hereby

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authorized and requested to charge Deposit Account No. 04-0100 for any such fees, and Applicant hereby petitions for any needed extension of time.